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# *Pacific-Rim Laser Damage 2026: Optical Materials for High-Power Lasers*

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# Contents

v Conference Committee

**PACIFIC-RIM LASER DAMAGE 2026: OPTICAL MATERIALS FOR HIGH-POWER LASERS**

14313 02 **Formation of residual stress in laser full-surface polished of fused silica** [14313-1]

14313 03 **Effects of substrate cleaning methods on laser-induced damage performance of three-wavelength antireflection coatings** [14313-2]

14313 04 **Thermal response of multilayer dielectric mirrors under dual-wavelength nanosecond laser irradiation** [14313-4]

14313 05 **Crystallization behavior of $HfO_2$ single-layer thin films: effects of thickness and deposition rate** [14313-5]

14313 06 **Effect of capping layer periodicity on contamination-induced degradation of broadband high-reflective films** [14313-6]

14313 07 **Learning-based lensless imaging through the nonlinear media** [14313-7]

14313 08 **Investigation of 1064 nm laser-induced breakdown threshold of $SF_6$ under variable pressures** [14313-8]

14313 09 **Picosecond laser damage characteristics and threshold enhancement of multilayer dielectric high-reflectivity coatings** [14313-9]

14313 0A **Study on the properties of UV-absorbing doped fused silica** [14313-10]

14313 0B **Broadband anti-reflection metasurface window fabrication technology for high-power lasers** [14313-11]